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FORM PTO-144 (REV.7-80)	9		U.S. DEPARTMENT PATENT AND TRAD		ATTY. DOCKET NO. 501082.02 (98-0616.	01)	APPLICATION NO. 09/652,994					
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1-1	AB	4,717,602	01/05/88	Yamazaki		427	583					
	AC	5,232,871	08/03/93	Но		438	653					
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1/109	AG	6,245,662	06/12/01	Naik et al		438	622					
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Sheet <u>1</u> of <u>1</u> ATTY, DOCKET NO. APPLICATION NO. U.S. DEPARTMENT OF COMMERCE **FORM PTO-1449** PATENT AND TRADEMARK OFFICE 09/652,994 (REV.7-80) 501082.02 (98-0616.01) APPLICANT(S) Vishnu K. Agarwal **ATION DISCLOSURE STATEMENT** (Use several sheets if necessary) FILING DATE **GROUP ART UNIT** 2815 August 31, 2000 JAN 3 0 2002 U.S. PATENT DOCUMENTS CLASS SUBCLASS FILING DATE CUMENT NUMBER DATE NAME IF APPROPRIATE 437 190 09/03/96 Hsieh 5,552,339 438 627 6,136,690 10/24/00 Li AΒ AC ΑD FOREIGN PATENT DOCUMENTS SUBCLASS TRANSLATION DATE COUNTRY **CLASS** DOCUMENT NUMBER YES NO X 355011329 A 01/26/80 JP (Abstract only) ΑE X JP (Abstract only) 410070091 A 03/10/98 ΑF OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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1	AA	5,552,341	09/03/96	Lee		437	192					
3	AB	5,843,843	12/01/98	Lee et al.		438	688					
	AC	5,913,145	06/15/99	Lu et al.		438	643					
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